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Bib Data Sheet

CONFIRMATION NO. 5241

SERIAL NUMBER 10/611,589	FILING DATE 06/30/2003  RULE	CLASS 148	GROUP ART UNIT 1742	ATTORNEY DOCKET NO. AMAT/1717.D2/CPES/DT/PJS
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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *Gu*

This application is a DIV of 09/513,734 02/18/2000 ABN  
 which is a CIP of 09/396,007 09/15/1999 PAT 6,276,072  
 and is a CIP of 09/263,126 03/05/1999 PAT 6,136,163

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *NONE - Gu*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 09/25/2003

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 8	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	EXAMINER'S SIGNATURE <i>[Signature]</i>	INITIALS <i>[Initials]</i>		
Verified and Acknowledged				

## ADDRESS

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## TITLE

Method and apparatus for annealing copper films

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees ( Filing )